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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8) Applicant(s): WENBING YUN ET AL.			Docket No.
			LBL-IB-1498-1
Serial No. 09/927,428	Filing Date AUGSUT 9, 2001	. Examiner	Group Art Unit 1765
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8) Docket No. Applicant(s): WENBING YUN ET AL. LBL-IB-1498-1 Serial No. Filing Date Examiner Group Art Unit 09/927,428 **AUGSUT 9, 2001** 1765 Invention: METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES I hereby certify that this Citations (3) (Identify type of correspondence) is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on November 14, 2001 (Date) JOHN P. O'BANION (Typed or Printed Name of Person Malling Correspondence) Note: Each paper must have its own certificate of mailing.